

10/523470
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10/523470
PATENT APPLICATION #3/A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI

Application No.: New U.S. National Stage of
PCT/JP03/010438

Filed: February 7, 2005

Docket No.: 122672

For: METHOD FOR MANUFACTURING MASK BLANK, METHOD FOR
MANUFACTURING TRANSFER MASK, SPUTTERING TARGET FOR
MANUFACTURING MASK BLANK

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Claims as reflected in the listing of claims;

Remarks.